## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:		)
	Tetsuro Inui et al.	ノ ) `
Serial No.	10/624,082	ノ ) `
Filing Date:	July 21, 2003	ノ ) `
Confirmation No.:	5995	) ) `
For:	DISPERSION MONITORING METHOD AND APPARATUS AND DISPERSION SLOPE TEMPERATURE DEPENDENCY COMPENSATION METHOD AND APPARATUS	,)))

## PRELIMINARY AMENDMENT

Commissioner for Patents PO Box 1450 Arlington, Virginia 22313-1450

Sir:

Prior to examination of the above-identified patent application, please enter the following amendments.